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**Bib Data Sheet** 

**CONFIRMATION NO. 3456** 

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	su, Fukushima, JAPAN			,			
Masashi Ichikawa, Fukushima, JAPAN; Nobuhiro Ohara, Fukushima, JAPAN;							
** CONTINUING DATA **********************************							
** FOREIGN APPLICATIONS ************************************							
Foreign Priority claimed 35 USC 119 (a-d) condition met Verified and Acknowledged Exa	STATE OR COUNTRY JAPAN	SHEETS DRAWIN 6	AWING CLAI		INDEPENDENT CLAIMS 3		
ADDRESS 25944							
TITLE Semiconductor wafer manufacturing method, semiconductor wafer mnaufacturing order acceptance method, and semiconductor wafer manufacturing order acceptance system							
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